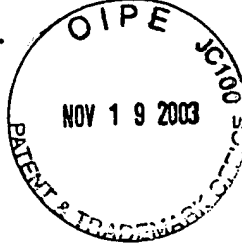


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Kenji Hoshi, et al.**

Serial No.: **10/073,314**

Filed: **February 13, 2002**



Group Art Unit: **2814**

Examiner: **Dana Farahani**

P.T.O. Confirmation No.: 4466

For: **SEMICONDUCTOR DEVICE AND ALIGNMENT SENSING METHOD FOR SEMICONDUCTOR DEVICE**

AMENDMENT UNDER 37 CFR §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

November 19, 2003

Sir:

In response to the Office Action dated August 8, 2003, please amend the above-identified application as follows:

RECEIVED
NOV 25 2003
TC 2800 MAIL ROOM